E UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Eiko Suzuki

Examiner:

Brian Q. Le

Serial No.:

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Dated:

November 22, 2005

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SEMICONDUCTOR WAFER

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT PURSUANT TO 37 C.F.R. § 1.111

Sir:

In response to the final Office Action dated June 22, 2005, Applicant respectfully requests under the provisions of 37 C.F.R. § 1.111 that the above-identified Application be amended as follows and that the Application be allowed.

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 22, 2005.

Dated: November 22, 2005

Richard J. Danyko